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Karen Cinq-Mars 7/23/03
(Signature & date)

GAU



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : July 23, 2003

Christopher Jahnes, et al. : Group Art Unit:

Serial No. 10/604,278 : Examiner:

Filed: 7/8/2003 : International Business Machines Corporation
2070 Route 52
Hopewell Junction, NY 12533

TITLE: NOBLE METAL CONTACTS FOR MICRO-ELECTROMECHANICAL SWITCHES

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

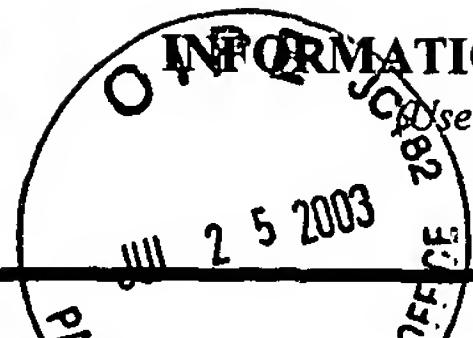
Pursuant to the duty of disclosure set forth in 37 C.F.R. 1.56, and further pursuant to the provisions of 37 C.F.R. 1.97 and 1.98, applicants hereby respectfully submit copies of the prior patents and publications as listed on Form PTO-1449, attached hereto.

In citing these documents, no representation is made nor intended as to the pertinency or non-pertinency of the art, that better art than that listed is not available, or that other art is not applicable.

No fee is believed to be due for this submission. If any fees are required, however, the Commissioner is hereby authorized to charge such fees to Deposit Account No. 09-0458.

Respectfully submitted,
David R. Hanson, et al.

By *H. Daniel Schnurmann*
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INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)

FIS920030061US1

Application Number

10/604,278

Applicant(s)

Hariklia Deligianni, et al.

Filing Date

7/8/03

Group Art Unit

U.S. PATENT DOCUMENTS

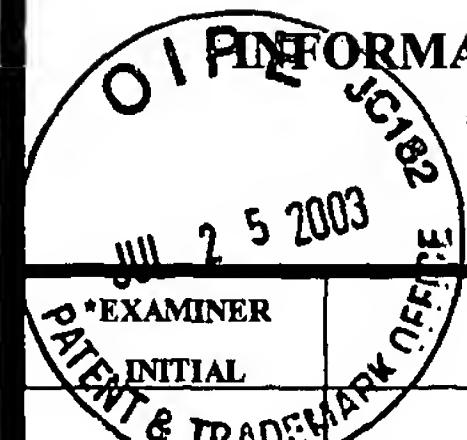
FOREIGN PATENT DOCUMENTS

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

		<p>"Microswitches and Microrelays with a View Toward Microwave Applications" Paul M. Zavracky, Nicol E. McGruer, Richard H. Morrison, David Potter, Northeastern University, Boston, Massachusetts 02115, Analog Devices Wilmington, Massachusetts 01887</p>
		<p>"Micromechanical Switches Fabricated Using Nickel Surface Micromachining" Paul M. Zavracky, Sumit Majumder, and Nicol E. McGruer, <i>Journal of Microelectromechanical Systems</i>, Volume 6, No. 1, March 1997</p>

EXAMINER _____ **DATE CONSIDERED** _____

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